IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.:	10/519,700		
Filing Date:	September 14, 2005		
Inventor(s):	Krull)	
Group Art Unit:	1765)	
Examiner Name:)	Angadi,Maki A) \	
Customer No.:	27160)	
Confirmation No.:	6925)	
Title: ION IMPLANTATION ION SOURCE, SYSTEM AND METHOD			

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action, mailed on August 5, 2008, please enter the following preliminary amendment.

Amendments to the Claims are reflected on page 2 of this paper.

Remarks begin on page 8 of this paper.